

<b>Notice of References Cited</b>	Application/Control No. 10/645,814		Applicant(s)/Patent Under Reexamination COUVILLON, LUCIEN A.	
	Examiner Danton DeMille		Art Unit 3764	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,249,076	06-2001	Madden et al.	310/363
*	B	US-2004/0230090	11-2004	Hegde et al.	600/018
	C	US-			
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	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

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**NON-PATENT DOCUMENTS**

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